

## **Europass Curriculum Vitae**



Babarada Florin

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## Personal information

First name / Surname

Address Telephones

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Nationality

Romanian

Gender

Male

## Desired employment / Occupational field

/ Actually University Professor

Work experience

Dates

2002-2007-2015-today

Occupation or position held

**Lecturer-Associate Professor-Professor** 

Main activities and responsibilities

Courses and applications: Technology Computer Aided Devices, Software Instruments in Microelectronics, Integrated Circuits Simulation and Design, Electronic Processes in Integrated Microstructures Simulation, Electronic Devices and Circuits

Name and address of employer

University Politehnica of Bucharest, Faculty of Electronics Telecommunication & Information

Technology, 1-3 Bd. Iuliu Maniu, 061071, Bucharest Romania

Type of business or sector

Education

Dates

2000-2002

Occupation or position held

**Production Director** 

Main activities and responsibilities

Improving the technological processes and organization of production activity and factory, drew up the technical documentation and began to implementation the standard of quality ISO 9001.

Name and address of employer

Type of business or sector

Rompac Group srl, Bucharest, Romania

Production

Dates

1999-2000

Occupation or position held

Designer

Main activities and responsibilities

Integrated circuits design

Name and address of employer

S. C. Baneasa S.A., Bucharest, Romania

Type of business or sector

Production

**Dates** 

1996-1999

Occupation or position held

**Research & Development Director** 

Main activities and responsibilities

Managing the activity of research & development department

Name and address of employer

Type of business or sector

S.C. Microelectronica S.A., Bucharest, Romania

Production

Dates

1993-1996

Occupation or position held

Main activities and responsibilities

Name and address of employer

Type of business or sector

Manager Photolithography and Masks Department

Management of department and MEMS project manager

Institute of Microtechnology-IMT, Bucharest, Romania

Research

Dates

1985-1993

Occupation or position held

Main activities and responsibilities

Name and address of employer

Type of business or sector

Manager Masks Fabrication Department

Masks and Intermediate Reductions Design, processing, cleaning and inspection

S.C. Microelectronica S.A., Bucharest, Romania

Production

Dates

1984-1985

Occupation or position held

Main activities and responsibilities Name and address of employer

Type of business or sector

**Head of Electric Department** 

Managing the activity of electrical department

Electric Cells, Bailesti, Romania

Production

Education and training

Dates

March 2014

Title of qualification awarded

**Trainer** 

Principal subjects/occupational skills

Name and type of organisation

Adults trainer

providing education and training

G.S. CONSULTING SERV SRL, Bucharest Romania

Dates

June 2013 **EC** expert

Title of qualification awarded

Principal subjects/occupational skills

Name and type of organisation providing education and training Nanosciences, Nanotechnologies, Materials, and new Production Technologies - NMP

Research European Commission, Covent Garden 2, Place Rogier, 16, 1210-Saint Josse, Brussels,

Belgium

**Dates** 

October 2012

Title of qualification awarded

Name and type of organisation providing education and training

Principal subjects/occupational skills

Transparent materials expert

Transparent materials fundamentals, synthesis and processing ORAMA Summer School, Crete, Greece

Dates

August 2009

Title of qualification awarded

Principal subjects/occupational skills

Name and type of organisation providing education and training

Nanoscience and nanotechnology expert

Issues of new materials nanoscience and nanotechnology

The Romanian Academy, Bucharest Romania

Dates

November 2008

Title of qualification awarded

Oxidised materials and applications for micro-nanoelectronics specialist

Principal subjects/occupational skills New aspects in oxidised materials and applications for micro-nano-electronics

Name and type of organisation National Institute for Research and Development in Microtechnologies-IMT. Bucharest Romania providing education and training **Dates** July 2008 Title of qualification awarded Nanosciences and nanotechnologies graduate Principal subjects/occupational skills 2<sup>nd</sup> International Summer School on Nanosciences and Nanotechnologies-NN08 Name and type of organisation Aristotle University of Thessaloniki, Thessaloniki Greece providing education and training Dates May 2008 Title of qualification awarded Metrology and characterisation for micro and nano technology expert Principal subjects/occupational skills Trends of metrology and characterisation for micro and nano technology Name and type of organisation The Centre of Excellence in Metrology for Micro and Nano Technologies, Loughborough UK providing education and training December 2005 **Dates** Title of qualification awarded Specialist MSt and MEMS Principal subjects/occupational skills The forth NEXUS IP and NoE workmeeting Name and type of organisation Ecole Nationale Supérieure d'Arts et Métiers, Paris, France providing education and training **Dates** 17-28 February 2003 Title of qualification awarded Quantum devices graduate Principal subjects/occupational skills Intensive course "Quantum Transport in Submicron Devices" - Wim Magnus, Wim Schoenmaker, IMEC-TCAD, Belgium Name and type of organisation EDIL R&D Centre on Microelectronics, University Politehnica of Bucharest, Romania providing education and training 1994-2000 Dates Title of qualification awarded Ph.D. Degree with thesis "Microresonant Sensors Fabricated on Silicon Wafers in Planar Technology" Name and type of organisation Faculty of Electronics and Telecommunications, University Politehnica of Bucharest, Romania providing education and training **Dates** 12 November-21 November 1990 Title of qualification awarded Training for Wafer Scanning Projection Lithography Name and type of organisation Electromat, Dresden, Germany providing education and training **Dates** 18 June-13 July 1990, 05 October-30 October 1987, 17 June-12 July 1985 Title of qualification awarded Training for Mask Projection Lithography Name and type of organisation Carl Zeiss Jena, Germany providing education and training

Dates 1988

Name and type of organisation providing education and training

Dates 1977-1983

Title of qualification awarded | Electronics Engineer

Name and type of organisation providing education and training

Faculty of Electronics and Telecommunications, University Politehnica of Bucharest, Romania

Dates

1972-1976

Title of qualification awarded

High school graduate

Name and type of organisation providing education and training

Electrotechnique High School, Craiova, Romania

## Personal skills and competences

Mother tongue Romanian

Other language(s)

Self-assessment

European level (\*)

English French

German

English, French, German

Understanding				Speaking				Writing	
Listening		Reading		Spoken interaction		Spoken production			
C1	Proficient User	C2	Proficient User	C1	Proficient User	C1	Proficient User	C1	Proficient User
C1	Proficient User	C1	Proficient User	B2	Independent User	B2	Independent User	В2	Independent User
B2	Independent User	B2	Independent User	B2	Independent User	B2	Independent User	B2	Independent User

<sup>(\*)</sup> Common European Framework of Reference for Languages

Social skills and competences

Strong referential values of fairness, equity and dignity. Ability to establish and maintain good working relations with people of different national and cultural backgrounds

Organisational skills and competences

Organised person, problem-solving attitude, good abilities for synthetic and global views over concrete situations

Technical skills and competences

Teaching, using and development of new tools for learning like the Intelligent e-Learning Environment and Adaptive e-Learning Systems

Managing the technical activity, production or research & development

New materials for transparent and bio-nano-microtechnologies

Modelling, simulation, design and fabrication of advanced semiconductor devices: MicroElectroMechanical Systems-MEMS, Solar Cells, Gas and Nuclear sensors, CMOS-IC

Technologies like: planar vacuum encapsulation, planarization, films deposition and process, characterization, techniques and microstructures for films mechanical characterisation, masks reticules and wafers lithography, electron beam pattern generation, wet and dry etching

**Technology Computer Aided Design** 

Precision and complex installations with mechanical, pneumatic, electronics and optical parts

Clean rooms and contamination control

Computer skills and competences

Ms. Office, AutoCAD, Cadstar, OrCAD, Mathcad, Mathlab, Corel Draw, Adobe, Tsuprem, Medici, Taurus, Athena, Atlas, TCAD-OMNI, Lotus, Ledit, Pascal, Visual Basic

Artistic skills and competences

Admirer of fine arts

Other skills and competences

Sport and travelling

Driving licence

Categories A and B

Additional information

General Association of Engineering from Romania-member The Institute of Electrical and Electronics Engineers-member

Annexes

List of books, papers, patents and projects